

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Michio WATANABE et al.

Application No.: 10/567,250

Confirmation No.: 3050

Filed: January 5, 2007

Art Unit: 2891

For: METHOD OF MANUFACTURING MICRO
TUNNEL-JUNCTION CIRCUIT AND MICRO
TUNNEL-JUNCTION CIRCUIT

Examiner: J. Doyle

REPLY TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Madam:

In reply to the Restriction Requirement dated July 2, 2009, the following remarks are respectfully submitted in connection with the above-identified application.

This reply includes:

Remarks